

## WEST Search History

DATE: Wednesday, September 13, 2006

Hide?	<u>Set</u> <u>Name</u>	<u>Query</u>	<u>Hit</u> <u>Count</u>
		<i>DB=USPT; PLUR=YES; OP=ADJ</i>	
<input type="checkbox"/>	L10	L9 and l7	8
<input type="checkbox"/>	L9	134/1,1.2.ccls.	1797
<input type="checkbox"/>	L8	5503964.pn.	1
<input type="checkbox"/>	L7	L6 same pressur\$5	62
<input type="checkbox"/>	L6	(wafer or substrate or semiconductor or workpiece) same (\$5resist or polymer) same (bak\$3 or heat\$3) same (ash\$3 with plasma)	273
		<i>DB=USPT,USOC; PLUR=YES; OP=ADJ</i>	
<input type="checkbox"/>	L5	(wafer or substrate or semiconductor or workpiece) same (\$5resist or polymer) same (bak\$3 or heat\$3) same (ash\$3 with plasma)	273
		<i>DB=EPAB,JPAB,DWPI; PLUR=YES; OP=ADJ</i>	
<input type="checkbox"/>	L4	L3 same pressur\$5	13
<input type="checkbox"/>	L3	(wafer or substrate or semiconductor or workpiece) same (\$5resist or polymer) same (bak\$3 or heat\$3) same (ash\$3 with plasma)	128
		<i>DB=USPT,USOC,EPAB,JPAB,DWPI; PLUR=YES; OP=ADJ</i>	
<input type="checkbox"/>	L2	(wafer or substrate or semiconductor or workpiece) same (\$5resist or polymer) same (bak\$3 or heat\$3) same (ash\$3 with plasma)	401
		<i>DB=USPT; PLUR=YES; OP=ADJ</i>	
<input type="checkbox"/>	L1	6302138.pn. or 6142168.pn.	2

END OF SEARCH HISTORY